



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 8, 2026	
IGI Report Number	LG806628031
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	6.92 X 6.88 X 5.02 MM

GRADING RESULTS

Carat Weight	2.02 CARATS
Color Grade	F
Clarity Grade	VS 1

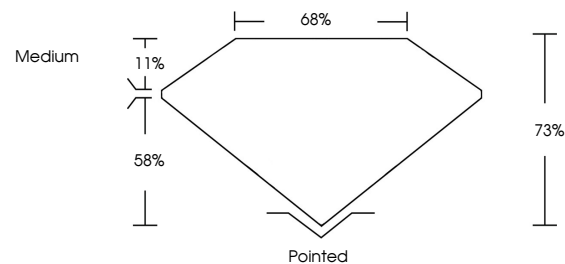
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG806628031

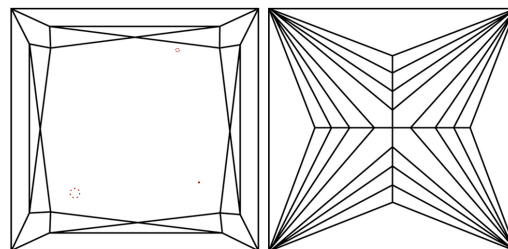
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG806628031
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

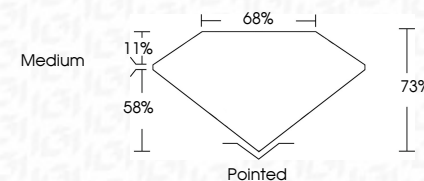
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June 8, 2026
GI Report No LG806628031
PRINCESS CIT

Carat Weight	2.02 CARATS
Color Grade	F
Clarity Grade	VS 1
Depth	73%
Table	68%
Grade	Medium
Culet	Pointed
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE

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created by Chemical Vapor Deposition
(CVD) growth process.